



PATENT

Atty. Dkt. No. AMAT/5730/TCG/WCVD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Yoo, et al.

Serial No.: 10/023,125

Confirmation No.: 4585

Filed: December 17, 2001

For: Pulse Nucleation Enhanced
Nucleation Technique for
Improved Step Coverage
and Better Gap Fill for
WCVD Process

MAIL STOP
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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§ Group Art Unit: 1765
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§ Examiner: Unknown
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CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on July 26, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

7/26/04

Date

Kris M. Yoo

Signature

RESPONSE TO NOTICE OF ABANDONMENT DATED JUNE 25, 2004

In response to the Notice of Abandonment dated June 25, 2004, please enter this Response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this Response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/5730/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.